



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Daisuke MUKAI, et al.

Art Unit : 1742

Serial No. : 10/566,433

Examiner : Unknown

Filing Date: January 31, 2006

Title : LOW Co HYDROGEN OCCLUSION ALLOY

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Customer Window
U.S. Patent & Trademark Office
Randolph Building
401 Dulany St.
Alexandria, Virginia 22314

Sir:

Pursuant to 37 C.F.R. 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. Copies of the references listed on Form PTO-1449 are attached.

The above information is presented so that the Patent and Trademark Office may, in the first instance, determine any materiality thereof to the claimed invention. See 37 C.F.R. 1.104(a) and 1.106(b) concerning the PTO duty to consider and use any such information. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that this reference be made of record therein and appear among the "References

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Cited" on any patent to issue therefrom.

Respectfully submitted,

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June 29, 2006
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Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office		Attorney's Docket No. 28950.0004	Application No. 10/566,433
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		<p style="text-align: center;">O P E R A T I O N JUN 29 2006 PATENT & TRADEMARK OFFICE</p>			
				Applicant Daisuke MUKAI, <i>et al.</i>	
				Filing Date January 31, 2006	Group Art Unit 1742
U.S. Patent Documents					
Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class Subclass Filing Date If Appropriate
	AA				
	AB				
	AC				

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Yes No
	AD	09-213319	08/15/1997	Japan			Abstract
	AE	2001-040442	02/13/2001	Japan			Abstract
	AF	2001-181763	07/03/2001	Japan			Abstract
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	AJ	2004-131825	04/30/2004	Japan			Abstract
	AK	WO 03/056047 A1	07/10/2003	WIPO			X
	AL						
	AM						
	AN						
	AO						

Other Documents (include Author, Title, Date, and Place of Publication)		
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	AP	
	AQ	

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EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	